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Docket No.: 0630-2627PUS1  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Young-Man JEONG et al.

International Application No.: PCT/KR2003/001451

Application No.: NEW

Art Unit: N/A

Filed: January 19, 2006

Examiner: Not Yet Assigned

For: PLASMA SURFACE PROCESSING SYSTEM  
AND SUPPLY DEVICE FOR PLASMA  
PROCESSING SOLUTION THEREFOR

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**PRELIMINARY AMENDMENT**

MS PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.